

Docket No.: 40959-157

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of

David ALMOGY, et al.

Serial No.: 09/641,137

Filed: August 16, 2000

Group Art Unit: 2877

Examiner: H. Pham

For: VARIABLE ANGLE ILLUMINATION WAFER INSPECTION SYSTEM

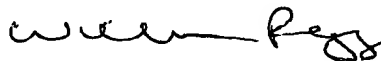
RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
Washington, DC 20231

Sir:

Noting the Office Action of September 17, 2001 wherein restriction has been required, Applicant(s) hereby elect, with traverse, Group I (claims 1-24), species b) (claims 8-11 and 19-22). Reconsideration and withdrawal of the restriction is requested in view of MPEP §803, which states that "if the search and examination of an entire application can be made without serious burden, the examiner must examine it on the merits, even though it includes claims to independent or distinct inventions." It is submitted that the pending claims of Group I are sufficiently related so as not to present serious burden on the Examiner's search and examination. Rejoinder is requested upon allowance of the generic claims.

Respectfully submitted,
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